

Docket No.: 4425-320

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	
	:	
Chien-Hsin LAI et al.	:	Confirmation No. 3535
	:	
Application No. 10/659,258	:	Group Art Unit: 1763
	:	
Filed: September 11, 2003	:	Examiner: KARLA A MOORE
For: PLASMA APPARATUS AND METHOD CAPABLE OF ADAPTIVE IMPEDANCE MATCHING		

**PETITION FOR EXTENSION OF TIME**


Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant(s) hereby petition(s) the Commissioner of Patents and Trademarks to extend the time for response to the Official Action dated September 12, 2006 for 1 month month(s) from December 12, 2006 to January 12, 2007.

A credit card authorization form to cover the cost of the extension is attached. Any deficiency or overpayment should be charged or credited to Deposit Account No.: 07-1337.

Respectfully submitted,  
**LOWE HAUPTMAN & BERNER, LLP**

  
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**DATE: January 12, 2007**  
BJH:AYW